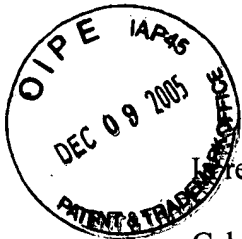


JB

TFW



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Here patent application of

Allowed: October 13, 2004

Cabral, Jr., et al.

Serial No.: 09/902,483

Group Art Unit: 2813

Filing Date: July 11, 2001

Examiner: Erik J. Kielin

For: SELF-ALIGNED SILICIDE (SALICIDE) PROCESS FOR LOW RESISTIVITY
CONTACTS TO THIN FILM SILICON-ON-INSULATOR AND BULK MOSFETS
AND FOR SHALLOW JUNCTIONS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REQUEST FOR ISSUED PATENT

Sir:

Applicant respectfully requests that the issued patent be forwarded to the undersigned.
The Issue Fee was paid on November 3, 2004, and as of this date, the undersigned has not
received the issued patent for the above-identified application.

Respectfully submitted,

Sean M. McGinn

Registration No. 34,386

Date:

12/9/05

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